

Notice of References Cited	Application/Control No. 10/566,327		Applicant(s)/Patent Under Reexamination OGAWA ET AL.	
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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-2002/0021264	02-2002	Nakamura, Tadashi	345/60
*	B	US-7,109,951	09-2006	Kim et al.	345/63
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	M	US-			

FOREIGN PATENT DOCUMENTS

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NON-PATENT DOCUMENTS

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